## Notice of References Cited Application/Control No. O9/807,131 Examiner Ted M. Wang Applicant(s)/Patent Under Reexamination HUTTUNEN, MIKKO Art Unit Page 1 of 1

## U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-6,058,138	05-2000	Fukumasa et al.	375/130
	В	US-			
	С	US-			
	D	US-			
	E	US-			
	F	US-			_
	G	US-			
	Н	US-			
	ı	US-			
	J	US-			
	Κ	US-			
	L	US-			
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	D					
	R			<del>"</del>		
	S					
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)					
	U						
	V						
	w						
	x						

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.